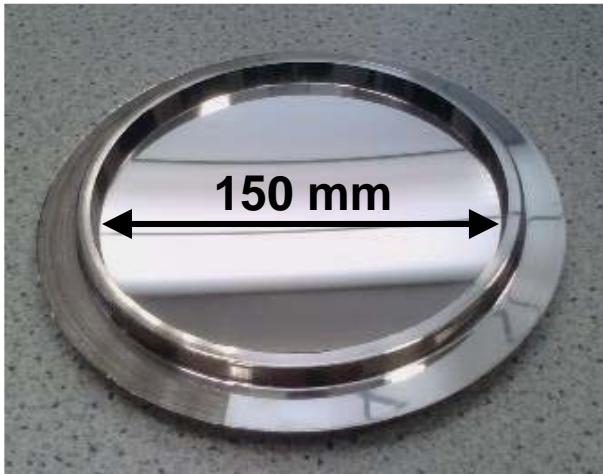


Technology addressing LPP source collectors



- Demonstrated sub-micron shape control on electroformed mirror
- 64% reflectivity MoSi multilayer coated on low-roughness electroformed samples

